



Tool Make & Model

Producer eXT

Tool Configuration / Specifications

Does not include: Dry pumps.

Process Type: Poly Etch

Software Version: 3.1

Number of Chambers 3 (A, B, C, D): 3(A, B, C)

Load Locks LL1, LL2: LL1, LL2

Transfer Chamber: Vacuum Robot

Process Chambers eXT Metal Etch Chambers: eXT Poly Etch

RF Generator: 13.56 MHz / Bias RF

Vacuum: Pump Turbo

ESC Type: Electrostatic Chuck

Temperature: Backside He Cooling

Endpoint Detection: Optical Emission Spectroscopy (if equipped)

Factory Interface: EFEM + FOUP Load Ports

Communications: SECS/GEM, GEM300

Utilities CDA, N₂, Process Gas, Cooling Water, Vacuum

Safety Systems: Gas Monitoring, Interlocks, EMO

Chamber Process

PM1: Metal Main Etch

PM2: Metal Main Etch

PM3: Metal Main Etch

Chillers: 3 pcs

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